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# ***Nanostructured Thin Films VIII***

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**Tom G. Mackay**  
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*Editors*

**12–13 August 2015**  
**San Diego, California, United States**

*Sponsored and Published by*  
SPIE

**Volume 9558**

Proceedings of SPIE 0277-786X, V. 9558

SPIE is an international society advancing an interdisciplinary approach to the science and application of light.

Nanostructured Thin Films VIII, edited by Akhlesh Lakhtakia, Tom G. Mackay, Motofumi Suzuki, Proc. of SPIE Vol. 9558, 955801 · © 2015 SPIE · CCC code: 0277-786X/15/\$18 · doi: 10.1117/12.2205187

Proc. of SPIE Vol. 9558 955801-1

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Author(s), "Title of Paper," in *Nanostructured Thin Films VIII*, edited by Akhlesh Lakhtakia, Tom G. Mackay, Motofumi Suzuki, Proceedings of SPIE Vol. 9558 (SPIE, Bellingham, WA, 2015) Article CID Number.

ISSN: 0277-786X

ISBN: 9781628417241

Published by

**SPIE**

P.O. Box 10, Bellingham, Washington 98227-0010 USA

Telephone +1 360 676 3290 (Pacific Time) · Fax +1 360 647 1445

SPIE.org

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